

**Sonnenschein**  
SONNENSCHN NATH & ROSENTHAL

One Metropolitan Square

Suite 3000

St. Louis, MO 63102

314.241.1800

314.259.5959 fax

www.sonnenschein.com

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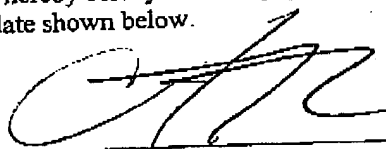
CLIENT/MATTER 9792909-5787

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Type of Paper transmitted: Amendment Under 37 C.F.R. § 1.111

Applicant's Name: Fumikatsu UESAWA

Serial No. (Control No.): 10/720,851

Examiner: Stephen W. Smoot

Filing Date November 24, 2003

Art Unit: 2813

Application Title: METHOD OF MANUFACTURING A SEMICONDUCTOR APPARATUS WITH A TAPERED APERTURE PATTERN TO FORM A PREDETERMINED LINE WIDTH

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Fumikatsu UESAWA

Group Art Unit: 2813

Application No.: 10/720,851

Examiner: Stephen W. Smoot

Filed: November 24, 2003

Confirmation No.: 5189

For: METHOD OF MANUFACTURING A SEMICONDUCTOR APPARATUS  
WITH A TAPERED APERTURE PATTERN TO FORM A PREDETERMINED  
LINE WIDTH

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
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**AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated June 29, 2004, please amend the  
above-identified application as follows.